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Ion source research and development at University of Jyväskylä: Studies of different plasma processes and towards the higher beam intensities


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Several ion source related research and development projects are in progress at the Department of Physics, University of Jyväskylä (JYFL). The work can be divided into investigation of the ion source plasma and development of ion sources, ion beams, and diagnostics. The investigation covers the Electron Cyclotron Resonance Ion Source (ECRIS) plasma instabilities, vacuum ultraviolet (VUV) and visible light emission, photon induced electron emission, and the development of plasma diagnostics. The ion source development covers the work performed for radiofrequency-driven negative ion source, RADIS, beam line upgrade of the JYFL 14 GHz ECRIS, and the development of a new room-temperature-magnet 18 GHz ECRIS, HIISI. © 2015 AIP Publishing LLC [http://dx.doi.org/10.1063/1.4934687]

I. EXPERIMENTAL PLASMA RESEARCH

Recent studies with the JYFL 14 GHz ECRIS1 indicate that anisotropy of the electron energy distribution function (EEDF) related to ECR heating results in plasma instabilities associated with strong microwave emission and burst of energetic electrons limiting the intensity of the highest charge states.2,4 The frequency and the amplitude of the instability event depend strongly on the magnetic field configuration, which limits the parameter space available for the production of the highest charge states. The experiments also suggest that the instabilities can be mitigated by 2-frequency heating.5,6

An experimental setup has been developed to study plasma induced photoelectron emission from different plasma chamber materials. The experiments have shown that the effect could have a contribution to properties of hydrogen ion source plasma. Recent experiments with the JYFL 14 GHz ECRIS have shown that the photon induced emission increases linearly with the microwave power and its maximum intensity can reach several milliampers per kilowatt of microwave power injected into the ion source. Further experiments are needed to define its effect on plasma properties, such as plasma potential, and on the performance of ECR ion sources. For further details see Refs. 7 and 8.

A project to study the visible light emission of highly charged ECRIS plasma has been initiated. The objective is to measure the light intensity emitted by different charge states in different operation conditions. The work will be performed first in the continuous wave (cw) operation mode by changing the ECRIS operation parameters such as microwave power and gas feeding rates. In the second step, the studies will focus on the transient plasma properties during the breakdown, also a short neutral gas pulse is introduced into the ECRIS plasma. The pulsing will be done using a fast gas-feeding valve developed for this purpose. The neutral gas pulse changes plasma conditions, which affects the charge state distribution and light emission of different charge states. The temporal behavior of ion beam intensities will be measured simultaneously with the light signals emitted by different charge states. This may reveal new information about the charge exchange process and about the electron energy distribution.

Figure 1 shows the visible light spectrum emitted by the argon plasma. The plasma was produced by the JYFL 14 GHz ECRIS with an output microwave power of 50 W and 400 W. Most of the visible light emission originates from neutral argon atoms and Ar$^{+2}$+ ions. However, some highly charged ions also emit photons in visible light range. As an example, emission from neutral argon atom and Ar$^{10+}$ ion has been identified in Fig. 1. As the figure shows, the light emission from Ar$^{10+}$ is negligible at the microwave power of 50 W while its intensity is comparable with the emission from neutral argon at the microwave power of 400 W. In the near future, the emissions from neutrals and different ions will be studied in different operation conditions. The relative changes of emitted signals will be recorded with the beam intensities in cw and pulsed operation mode and also when a short pulse of neutral gas is introduced into the plasma.

The VUV emission of filament-driven arc discharge and microwave discharge has been studied using optical filters and photodiodes. These developed diagnostics yield information.
for example, about the VUV emission power and different volumetric production rates. For further details see Refs. 9–13.

II. DEVELOPMENT OF ION SOURCES AND THEIR BEAMS

To meet the future requirements of the JYFL nuclear physics programs and to offer high quality research infrastructure, a major investment on the ion source and accelerator facilities is needed. At the end of 2013, the Academy of Finland funded the JYFL Accelerator Laboratory to design and construct an 18 GHz ECR Heavy Ion Source Injector (HIISI[14,15]). The physical design started at the beginning of 2014 and the engineering design of the main components was completed at the beginning of 2015. The main components for the generation of magnetic field will arrive by November 2015 and the first ion beam will be extracted by summer 2016.

A. Rearrangement of ion source area

In order to have enough space for new 18 GHz ECRIS, the filament driven H⁻ ion source (called LIISA),[16] 6.4 GHz ECRIS,[17] and 14 GHz ECRIS have to be relocated. The JYFL 14 GHz ECRIS was moved close to the 90° bending magnet in May 2015. In the new location, the intermediate focal point of high charge states between the ion source and the mass separation is avoided, which possibly decreases the space charge problems experienced in this beam line section. At the same time, the entrance and exit angle of the dipole magnet were optimized in order to have the focal point in both transverse planes at the same distance. The H⁻ ion source and 6.4 GHz ECRIS will be moved to new location by the end of October 2015.

B. RF driven ion source (RADIS) for negative light ions

The RADIS RF (13.56 MHz) ion source is under development for replacing the filament-driven H⁻ ion source of the MCC30/15 cyclotron. The main objective is to increase the mean time between maintenance works from a few days to months. The performance of RADIS has steadily increased and is approaching goal intensity level of 1 mA/kW of RF power at the beam energy of 19 keV (achieved: 0.7 mA/1 kW/6 mm extraction aperture). For further details see Refs. 18 and 19.

C. HIISI: 18 GHz ECRIS for the K130 cyclotron

The objective of HIISI is to produce intense, medium charge state ion beams, such as Ar⁵⁺/M/q ≈ 5, E ≈ 5 MeV/u). However, a very challenging requirement is also set by the research programs demanding highly charged, high-energy heavy ion beams (M > 100, E > 15 MeV/u). As an example, about 1 nA of accelerated Xe⁴⁴⁺ ion beam is needed for the program. This corresponds to at least 10 nA of extracted ion beam from the ECRIS. Figure 2 shows the xenon ion beam intensities extracted from various well performing ECR ion sources. The requested ion beam is denoted by a red circle. The performance requirement can be met by 3rd generation ECR ion source such as VENUS and SUSI.[20,21] In the case of SUSI, the presented intensities were achieved by using 18 GHz operation frequency. More importantly, the same SUSI magnetic field configuration can be produced with room temperature magnets and this is the design base for HIISI.

Table I shows the magnetic field configuration of SUSI when it has been tuned for the production of highly charged xenon ion beams using 18 GHz operation frequency. The table shows also the magnetic field configuration of HIISI confirming that the axial magnetic field strength needed for efficient operation at 18 GHz can be met. The plasma chamber of both ion sources is 100 mm in diameter. Relatively large plasma chamber volume together with a high axial magnetic field requirement (B_{inj} = 2.7 T and B_{ext} = 1.5 T) results in a power consumption of about 210 kW for HIISI. Decreasing the extraction field from about 1.5 T to 1.3 T,
i.e., close to $B_{\text{rad}}$, should reduce the power consumption to about 150 kW.

The experimental data and simulations\textsuperscript{22} suggest that low magnetic field gradient at resonance results in efficient electron heating and consequently anisotropic velocity distribution. The anisotropy results in unstable plasma behavior being detrimental especially for the production of highly charged ions. Because of this concern, the gradient of axial magnetic field was used as one design parameter of HIISI. As the table shows, the gradients of the axial magnetic field of SUSI and HIISI are practically identical. The plasma length $L$ of HIISI slightly exceeds the plasma length of SUSI. Here, the plasma length $L$ is the distance between the axial resonance points for the non-relativistic electrons.

As Table I shows, the radial magnetic field $B_{\text{rad}}$ was 1.36 T when SUSI was tuned for the production of highly charged xenon ion beams. This magnetic field value is very difficult to achieve by using permanent magnets. However, the properties of permanent magnet, such as remanence magnetic field $B_{\text{rem}}$ and coercive force $H_{\text{ci}}$, improve when the temperature of the magnet decreases. The lower temperature allows the use of magnet grade with a high $B_{\text{rem}}$ thanks to the $H_{\text{ci}}$ increase, leading to a higher sextupole magnetic field at the plasma chamber wall.

This low temperature induced property improvement is exploited in HIISI to maximize the radial magnetic field ($B_{\text{rad}}$). The permanent magnet multipole will be vacuum insulated from the surrounding structures, especially from the plasma chamber, to ensure efficient cooling of the permanent magnets. The objective is to operate the permanent magnets close to $-20^\circ\text{C}$, which would increase the coercivity force approximately by 50% when compared to room temperature. The structure also allows to keep the distance between the inner surface of the plasma chamber and the permanent magnet below the typical value of 5 mm. This distance has to be minimized in order to maximize the value of $B_{\text{rad}}$ at the plasma chamber wall.

The main heat load on the vacuum insulated permanent magnet blocks comes from the heat transfer by the residual molecules inside the vacuum gap and by the heat radiation. The conductive heat load through the insulated support structures is negligible. The sextupole chamber has a dedicated cooling circuit, which makes it possible to keep the magnets below the freezing point. Such a design with improved coercivity of the permanent magnets offers a good safety margin against the demagnetization and also allows the use of stronger magnet grade (in terms of $B_{\text{rem}}$). Comprehensive heat load simulations have been presented in Ref. 15.

The nominal values of the permanent magnet grade selected for HIISI at 20 $^\circ\text{C}$ are $B_{\text{rem}} = 1.33$ T and $H_{\text{ci}} = 1595$ kA/m. Figure 3 shows the demagnetization analysis when the solenoids are excited to produce $B_{\text{maj}}$ and $B_{\text{ext}}$ values listed in Table I. The analysis indicates that inside the most critical magnet volume the demagnetizing field is close to the maximum value the permanent magnet can withstand. Consequently, it is of great importance that the permanent magnets are kept below room temperature and their temperature is monitored. The different heat expansion coefficient in perpendicular and parallel direction with respect to the magnetization vector might cause some technical challenges but the final objective is to reach a safe operation condition below the freezing point (close to $-20^\circ\text{C}$). This would allow the use of stronger permanent magnets and thus to reach a radial magnetic field of about 1.4 T.

Figure 4 shows the structure of the plasma and sextupole chambers. Careful considerations and simulations were performed in order to maximize the heat transfer from the aluminum plasma chamber to cooling water. Thermal simulations indicate the plasma chamber should withstand input microwave power up to 5 kW. At this power, the peak temperature of plasma chamber, corresponding to the highest plasma flux area, is slightly above 100 $^\circ\text{C}$ which is close to the maximum safe operation temperature of an aluminum plasma chamber.

Figure 5 shows the cross section of the JYFL 18 GHz ECRIS. Its minimum-B field strength supports plasma heating frequency of 14.5 GHz and 18 GHz simultaneously. In
addition, the plasma can be heated using two independent heating frequencies between 14.5 and 18 GHz making 4-frequency heating possible. The fourth frequency may offer further improvement especially in the case of the highest charge states.

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